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APPLICATION N	0.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/028,778		12/28/2001	Hiroaki Tanaka	GNE463A	4276
466	7590	03/01/2004		EXAM	INER
YOUNG	& THO	MPSON	ERDEM, FAZLI		
745 SOU	ΓH 23RD	STREET 2ND FLO	OOR		
ARLING	ΓΟΝ, VA	22202	ART UNIT	PAPER NUMBER	
	•			2826	

DATE MAILED: 03/01/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)				
	10/028,778	TANAKA ET AL.				
Office Action Summary	Examiner	Art Unit				
	Fazli Erdem	2826				
The MAILING DATE of this communication ap Period for Reply	opears on the cover sheet with the c	orrespondence address				
A SHORTENED STATUTORY PERIOD FOR REPI THE MAILING DATE OF THIS COMMUNICATION - Extensions of time may be available under the provisions of 37 CFR 1 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a re - If NO period for reply is specified above, the maximum stututory period - Failure to reply within the set or extended period for reply will, by statu Any reply received by the Office later than three months after the maili earned patent term adjustment. See 37 CFR 1.704(b).	136(a). In no event, however, may a reply be timply within the statutory minimum of thirty (30) days will apply and will expire SIX (6) MONTHS from te, cause the application to become ABANDONE	nety filed s will be considered timely. the mailing date of this communication. C (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on 05	December 2003.					
	is action is non-final.					
, –	·					
Disposition of Claims						
 4a) Of the above claim(s) is/are withdress 5) ⊠ Claim(s) 22-53 is/are allowed. 6) ⊠ Claim(s) 1,3,5 and 12-14 is/are rejected. 7) ⊠ Claim(s) 2,4,6-11 and 15-21 is/are objected to 	Claim(s) 1,3,5 and 12-14 is/are rejected.					
Application Papers						
9) The specification is objected to by the Examin 10) The drawing(s) filed on is/are: a) ac Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Examin 11.	cepted or b) objected to by the E e drawing(s) be held in abeyance. See ction is required if the drawing(s) is obj	e 37 CFR 1.85(a). ected to. See 37 CFR 1.121(d).				
Priority under 35 U.S.C. § 119						
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 						
Attachment(s)						
1) Notice of References Cited (PTO-892)	4) 🔲 Interview Summary Paper No(s)/Mail Da					
 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08 Paper No(s)/Mail Date 		atent Application (PTO-152)				

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DETAILED ACTION

Allowable Subject Matter

1. Claims 22-53 allowed.

2. Claims 2, 4, 6-11 and 15-21 objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1, 3, 5 and 12-14 rejected under 35 U.S.C. 103(a) as being unpatentable over Yamazaki et al. (6,489,632) in view of Fujikawa et al. (5,995,177) further in view of Kitakado et al. (6,461,899).

Regarding Claims 1, 3, 5 and 12-14, Yamazaki et al. disclose a semiconductor device having a gate oxide film where a MIS type semiconductor device and a method for fabricating the same characterized in that impurity regions are selectively formed on a semiconductor substrate or semiconductor thin film and are activated by radiating laser beams or a strong light equivalent from above so that the laser beams or the equivalent strong light are radiated onto the impurity regions and on a boundary between the impurity region and an active region adjoining the impurity region. Yamazaki et al. fail to disclose the required nitrogen concentration in a metal nitride structure and the required nitrogen concentration in an TiN structure. However,

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Fujikawa et al. disclose an active matrix substrate with multi-layer signal lines and/or electrodes where the required nitrogen concentration in a metal/nitride structure is disclosed. Furthermore, Kitakado et al. disclose a oxynitride laminate blocking layer for thin film semiconductor devices where the required nitrogen concentration in a TiN structure is disclosed.

It would have been obvious to one of having ordinary skill in the art at the time the invention was made to include the required nitrogen concentration in a metal nitride structure and the require nitrogen concentration in a TiN structure in Yamazaki et al. as taught by Fujikawa et al. and Kitakado et al. respectively in order to have a liquid crystal display device with higher performance.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Fazli Erdem whose telephone number is (703) 305-3868. The examiner can normally be reached on M - F 8:00 - 5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nathan Flynn can be reached on (703) 308-6601. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

FE February 23, 2004

Alexander Williams Primary Edeminer